

Growth Mechanism of Lithium Phosphorus Oxynitride(Lipon) by Rf Magnetron Sputter

Keun-Man Song, Kwang-Soon Ahn, Hyo-Jin Ahn,

Woo-Seong Kim, and Yung-Eun Sung

Dept. of Materials Science & Engineering

Kwangju Institute of Science and Technology

Kwangju, 500-712, Korea

With advances in fabrication and integration of micro or nano-device, small or micro size power source is also necessary to realize small size electronics. Microbattery (or thin film battery) is a promising micropower source, which is fabricated all solid state. Lipon (Lithium phosphorus oxynitride) has recently attracted an attention as a promising candidate as a solid state electrolyte for lithium microbattery [1, 2]. Lipon has good lithium ion conductivity (3.3×10^{-6} S/cm at 25°C) and is stable in contact with lithium metal at large potential window from 0 to 5 V [2].

The Lipon film was deposited on Si substrate by rf magnetron sputter system. The Li_3PO_4 target was sputtered with the rf power of 3 W/cm^2 in a pure N_2 . Investigations on the microscopic structural and surface properties of Lipon have been developed using optical microscopy and atomic force microscopy (AFM). *ac* impedance spectroscopy and cycler were used for the electrochemical properties of this film.

Fig. 1 shows optical microscopic images (x 500) which present the evolution of Lipon layer morphology with increasing thickness. For a thickness of 1300 \AA , the morphology is dominated by many pits and islands. Increasing the layer thickness to 6000 \AA decreases the number of pits. In contrast, at 9000 \AA for the Lipon, it is observed that the large size and number of pits are formed on surface. However, increasing the thickness of Lipon layer, the microscopic surface morphology is smoothed and the number of islands is decreased, as shown in Fig. 2. (by AFM image $5 \mu\text{m} \times 5 \mu\text{m}$)

A growth mechanism for Lipon at early stage of the deposition process will be also discussed.

The relation between the growth process, the

microstructure and electrochemical properties of Lipon on Si substrate will be presented.

Reference

- [1] J. B. Bates, N. J. Dudney, G. R. Gruzalski, R. A. Zuhr, A Choudhury, C. F. Luck, J. D. Robertson, 6th International Meeting on Lithium Battery, J. Power Sources 43 (1993) 103.
- [2] X. Yu, J. B. Bates, G. E. Jellison. Jr, F. X. Hert, J. Electrochem. Soc. 144 (1997) 524.

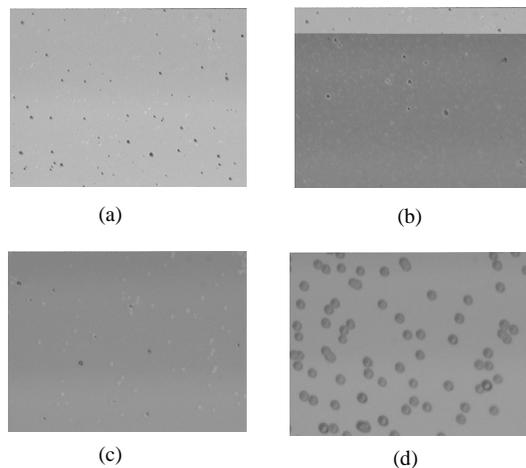


Fig. 1 Surface morphology of the Lipon with thickness (a) 1300 \AA (b) 3200 \AA (c) 6000 \AA (d) 9000 \AA

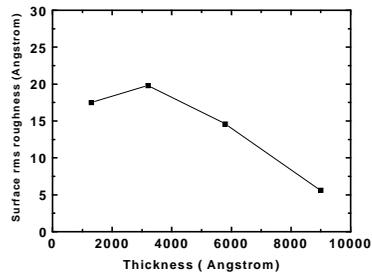


Fig. 2 Surface rms roughness of Lipon film